

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Inventor(s): JASPER

Atty.Dkt: 81468/257643

Appln. No.: 09/519,875

Filed: March 6, 2000

FOR: OFF-AXIS LEVELING IN LITHOGRAPHIC PROJECTION APPARATUS



Group Art Unit:

Examiner:

Date: March 21, 2000

IDS LETTER CITING APPLICATION

The Examiner's attention is directed to the following application of:

Examiner's Initials*	FIRST INVENTOR (Last Name Only)	APPLICATION NO. (Series Code/Serial No.)
	KRUIZINGA	09/521,599

PLEASE DO NOT PRINT the above information on the patent which results from the subject application.

This application is being filed within three months of the application filing date.

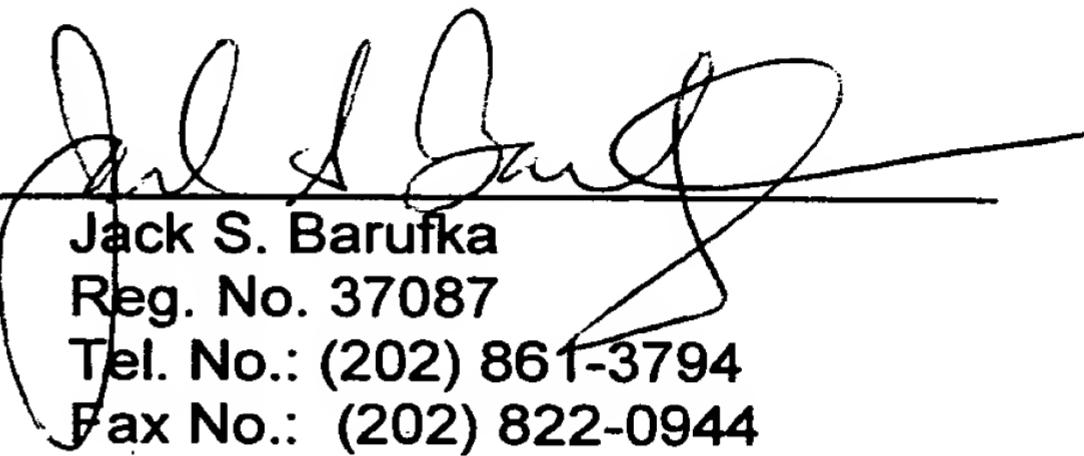
Consideration of the listed application is earnestly solicited since unpublished patent applications are contemplated as IDS material; see the exception in Rule 98(a)(ii) and note the penultimate sentence of MPEP 609.

Further, in keeping with MPEP 609, Subsec. C(2), 2nd para., line 10 to end of the paragraph (especially note lines 18-25) **PLEASE RETURN A COPY OF THIS LETTER** with the Examiner's initials adjacent the above listing so that applicant will know that the listed application has been considered as required by PTO policy. Thanks.

Respectfully submitted,

PILLSBURY MADISON & SUTRO LLP

By


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*The Examiner's initials adjacent a citation indicates he/she has considered the cited application relative to the subject application.